

Substitute for form 1449A/PTO (modified)

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Page 1 of 3

Application Number

10/647523

Filing Date

August 25, 2003

First Named Inventor

Jing, Naiyong

Art Unit

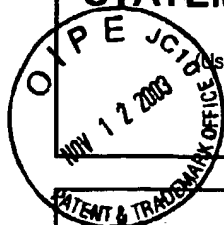
1773

Examiner Name

ZACHARIA

Attorney Case Number

56210US004



U.S. Patent Documents

Exam. Init.*	Cite No.	Document Number	Publication Date or Issue Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Doc. Number-(Kind Code if Known)			
REZ	A1	US- 2,789,063	04/16/1957	Purvis et al	
REZ	A2	US- 3,563,871	02/16/1971	Newman et al	
REZ	A3	US- 4,112,139	09/05/1978	Shirk et al	
REZ	A4	US- 4,164,463	08/14/1979	Fang	
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REZ	A11	US- 4,824,692	04/25/1989	Gillick et al	
REZ	A12	US- 4,912,171	03/27/1990	Grootaert et al	
REZ	A13	US- 5,051,312	09/24/1991	Allmér	
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REZ	A15	US- 5,262,490	11/16/1993	Kolb et al	
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		Doc. Number (Kind Code if Known)			
REZ	A29	US- 6,117,497	09/12/2000	Murahara et al	
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Exam. Init.*	Cite No.	Foreign Patent Document		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation (Check if yes)
		Ctry. Code	Number-Kind Code (If known)				
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REZ	B2	JP	07-179628	07/18/1995			X Abstract only
REZ	B3	JP	07-179636	07/18/1995			X Abstract only
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Exam. Init.*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published
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REF	C8	Clark, D.T.; Hutton, D.R.; <u>Journal Polym. Sci., Polym. Chem. Ed.</u> , 1987, Vol. 25, p. 2643
	C9	Weismann, S.I.; <u>Journal Phys. Chem.</u>, 1954, Vol. 22, p. 1135
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REF	C15	MacNicol, D.D.; Robertson, C.D.; <u>Nature</u> , 1988, 332, 59
REF	C16	Cooper, D.L.; Allan, N.L.; Powell, R.L.; <u>Journal Fluorine Chem.</u> , 1990, Vol. 49, p. 421
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REF	C21	Plueddemann, E.P.; <u>Silane Coupling Agents</u> , 1982, Plenum Press, NY, pp. 188-205
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REF	C23	<u>Chemlok® 607</u> , "Silicone Rubber & Specialty Elastomer Adhesive", Lord Corporation
REF	C24	<u>Semiconductor International</u> , 11, Burggraf, Pieter, No. 8, Vol. 5, (1988)
REF	C25	Related Application U.S. Serial No. 09/862,124, filed May 21, 2001, Attorney Docket No. 56211US002, now Publication No. 2002-0197481-A1
REF	C26	Related Application U.S. Serial No. 09/862,125, Filed May 21, 2001, Attorney Docket No. 56212US002, now allowed

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